



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Gaku MINAMIHABA et al.) Group Art Unit: 2818
Application No.: 10/771,060) Examiner: Goodwin, David J.
Filed: February 4, 2004))
For: POLISHING PAD AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICES) Confirmation No.: 2231))

Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(d)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(d), Applicants bring to the attention of the Examiner the documents on the attached listing. This Information Disclosure Statement is being filed after a Final Action and is accompanied by a fee of \$180.00 as specified under § 1.17(p) and a certification as specified under § 1.97(e).

Each document listed in this Information Disclosure Statement was first cited in a Notification of Reasons for Rejection ("Notification") mailed September 19, 2006, from the Japanese Patent Office in a counterpart foreign application, and this Information Disclosure Statement is being filed within three months of the mailing date of that communication.

Copies of the listed foreign documents are attached. In lieu of a statement of relevance or translation of the non-English documents, an English language version of

10/26/2006 SDENBOB1 00000006 10771060 01 FC:1806 180.00 OP

Application No.: 10/771,060

Attorney Docket No. 04329.3238

the Notification setting forth the relevance of the documents is enclosed. A copy of the

Notification is also enclosed for the Examiner's convenience. Applicants do not

necessarily endorse the conclusions set forth in the Notification.

Applicants respectfully request that the Examiner consider the listed documents

and indicate that they were considered by making appropriate notations on the attached

form.

This submission does not represent that a search has been made or that no

better art exists and does not constitute an admission that each or all of the listed

documents are material or constitute "prior art." If the Examiner applies any of the

documents as prior art against any claims in the application and Applicants determine

that the cited documents do not constitute "prior art" under United States law,

Applicants reserve the right to present to the office the relevant facts and law regarding

the appropriate status of such documents.

Applicants further reserve the right to take appropriate action to establish the

patentability of the disclosed invention over the listed documents, should one or more of

the documents be applied against the claims of the present application.

If there is any additional fee due in connection with the filing of this Statement,

please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,

GARRETT & DUNNER, L.L.P.

Dated: October 25, 2006

By:

Selah C. Park

Reg. No. 57,127

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IDS Form PTO/	/SB/08: Substitute for form 1449A/PTO			C	F 2000	
				Application Number	10/771,060	OCT 2 5 2006
INF	ORMATION D	ISCLOSE	JRF	Filing Date	February 4, 2004	\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\
STATEMENT BY APPLICANT				First Named Inventor	Gaku MINAMIHABA e	t al.
STATEMENT OF APPLICANT			Art Unit	2818	HADEM	
	(Use as many sheets	as necessary)		Examiner Name	Goodwin, David J.	
Sheet	1	of	1	Attorney Docket Number	04329.3238	

	U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS						
Examiner Cite No.1	Document Number	Issue or	Name of Patentee or	Pages, Columns, Lines, Where			
	No.'	Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Applicant of Cited Document	Relevant Passages or Relevant Figures Appear		
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Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. ¹	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation ⁶
	-	JP 2000-034416	02-02-2000			No
		JP 2001-214154	08-07-2001			No

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶	
		Copy of Japanese Office Action entitled "Notification of Reasons for Rejection" mailed by the Japanese Patent Office on September 19, 2006 in counterpart Application	Yes	

Examiner	Date	
Signature	Considered	
Signature		

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.